



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Van den Bergh et al. ) Docket: 27500-200  
Serial No.: 10/784,851 ) Examiner: Lee  
Filing Date: 2/23/2004 ) Group Art Unit: 2884  
Title: STORAGE PHOSPHOR PANEL RADIATION ) Conf. No: 9445  
IMAGE SENSOR AND METHODS OF )  
MAKING SAME )

RESPONSE TO OFFICIAL ACTION UNDER 35 U.S.C. 1.113

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The remarks and amendments are submitted in response to the  
Office Action mailed November 7, 2006.

The response is submitted within two months of the mailing  
date of the Official Action.

No fees are due.

The application is now believed to be in condition for  
allowance and reconsideration in light of the following is  
respectfully requested. Alternatively, the response places the  
application into better condition for appeal. Applicant  
respectfully request that the response and amendments be  
entered.

12/19/2006 HVUONG1 00000056 080719 10784851

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